

ELIMINATOR™ CA

Room Temperature Purifiers for Inert Gases and Hydrogen



Eliminator[™] Model 600 CA

APPLICATIONS

- Semiconductor Industry
- **High Purity Welding**
- Inert Gas Purge
- Gas Cylinder Cabinets
- Gas Analyzer Carts
- **Research and Development**

- Removal of impurities to < 1 ppb
- No heaters or power required
- Room-temperature operation
- 316L SS (<10 Ra EP) vessel
- Factory regenerable for up to 10 year life

FEATURES

- Field regenerable for up to 10 year life
- Improved process equipment performance
- Optional built-in 0.003 µm filter (PF-Series)
- High Flow up to 300 slpm
- Low cost (initial and operating)

NuPure's Eliminator[™] CA Gas Purifiers reduce gaseous impurities to sub-ppb levels at room temperature operation. The Eliminator[™] removes H₂O, O₂, CO, CO₂, H₂ and NMHC's to <1 ppb from any inert gas (Nitrogen, Argon, Helium, Krypton, Neon and Xenon) and H₂O, O₂ and CO₂ from Hydrogen. They are ideally suited to purifying gases from liquid sources.

The NuPureTM EliminatorTM Catalyst/Absorber (CA) chemistry represents a major improvement over catalystonly purifiers. For example, the moisture capacity of the NuPureTM Model 600 CA is more than *three times* the moisture capacity of the Aeronex Model 500!

The NuPure Eliminator[™] CA gas purifiers come in standard size ranges from 0 to 300 slpm, in standard size ranges from 0 to 300 slpm, with the high-flow purifier versions (XL Series) especially suitable for applications such as welding or purging. The use of factory-installed inlet isolation valve is recommended for ease of installation and elimination of possible operator error.

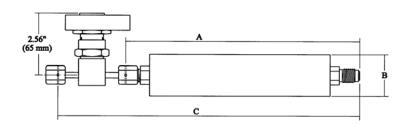
Gas	Version	H ₂ O	0 ₂	CO ₂	СО	N ₂	H ₂	NMHC	Particles ¹
N ₂	XL or PF	< 1 ppb	< 1 ppb	< 1 ppb	< 1 ppb	-	< 1 ppb	< 1 ppb	$< 1~\text{pcf}$ down to 0.01 μm
Noble	XL or PF	< 1 ppb	< 1 ppb	< 1 ppb	< 1 ppb	N / R^2	< 1 ppb	< 1 ppb	<1 pcf down to 0.01 μm
H ₂	XL or PF	< 1 ppb	< 1 ppb	< 1 ppb	N / R ²	N / R^2	-	< 1 ppb	<1 pcf down to 0.01 μm

IMPURITIES REMOVED

1 Particle removal is guaranteed with PF version only 2 N / R = Not Removed. Removal of all impurities can be accomplished using *heated getter* gas purifiers. See brochures for the NuPure[™] PF Series® and Omni[™] Series Purifiers.

NuPure[™] ELIMINATOR[™] CA

Dimensional and Performance Specifications



Purifier Model ¹	A in (mm)	B in (mm)	C in (mm)	Average Flows @ 1 yr regeneration	Max Flow ² @ 130 psig	
E 40 I	4.5 (114)	1.0 (25)	7.3 (185)	0.3 slpm	4.5 slpm	
E 100 I	4.5 (114)	1.5 (38)	7.3 (185)	0.8 slpm	12 slpm	
E 200 I	7.5 (190)	1.5 (38)	10.3 (262)	2 slpm	30 slpm	
E 600 I	10.4 (265)	2.0 (51)	13.2 (336)	6 slpm	90 slpm	
E 1000 I	15.4 (392)	2.0 (51)	18.2 (463)	10 slpm	150 slpm	
E 2000 I	22.8 (579)	2.5 (64)	25.7 (649)	20 slpm	300 slpm	
E 40 H2	4.5 (114)	1.0 (25)	7.3 (185)	1.5 slpm	4.5 slpm	
E 100 H2	4.5 (114)	1.5 (38)	7.3 (185)	4 slpm	12 slpm	
E 200 H2	7.5 (190)	1.5 (38)	10.3 (262)	10 slpm	30 slpm	
E 600 H2	10.4 (265)	2.0 (51)	13.2 (336)	30 slpm	90 slpm	
E 1000 H2	15.4 (392)	2.0 (51)	18.2 (463)	50 slpm	150 slpm	
E 2000 H2	22.8 (579)	2.5 (64)	25.6 (649)	100 slpm	300 slpm	
Maximum Pressure250 psig (USA) / 9.9 kg/cm2G (Japan)Materials316L SS (<10 Ra EP) finish						
Operating Temper	ature Room Ten	nperature	Fittings	1/4" VCR ³	1/4" VCR ³	
Leak Rate	< 2 x 10 ⁻⁹	atm cc/sec He	Gas Inlet	VLSI grade (99.9995% minimum)		

1 - Select "I" for Inert Gases; Select "H2" for Hydrogen, or Hydrogen Mixes (e.g. N₂/H₂, Ar/H₂)

2 - Operation at high flow may result in a high pressure drop. Contact factory for technical assistance.

3 - VCR compatible fitting standard. VCR® is a registered trademark of Cajon Corporation.

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